

Notice of References Cited

Application/Control No.

10/595,191

Applicant(s)/Patent Under
Reexamination
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Examiner

NICHOLAS LEE

Art Unit

2627

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0114474 a1	06-2004	Park et al.	369/030.05
*	B	US-2004/0223440 a1	11-2004	Park, Yong Cheol	369/059.25
*	C	US-5,825,726	10-1998	Hwang et al.	369/30.05
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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